

SUPPLEMENTAL APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Number:: 10/533,810
Application Date:: 05/05/05
Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?: NONE
Title:: METHOD OF FORMING FILM ON
SUBSTRATE
Attorney Docket Number:: 271672US2PCT
Total Drawing Sheets:: 6

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Shigeki
Family Name:: SAKAI
City of Residence:: Ibaraki
Country of Residence:: Japan
Street of Mailing Address:: c/o National Institute of Adv. Indus. Sci. &
Tech., Tsukuba Central 2, 1-1-1
Umezono, Tsukuba-shi
City of Mailing Address:: Ibaraki
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 305-8568

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

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|------------------|-------------------|----------------------|----------------------|
| Application:: | Continuity Type:: | Parent Application:: | Parent Filing Date:: |
| This Application | National Stage of | PCT/JP03/14188 | 11/07/03 |

FOREIGN PRIORITY INFORMATION

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|---------------------|-----------|---------------|--------------------|
| Application Number: | Country:: | Filing Date:: | Priority Claimed:: |
| 2002-325000 | | | |

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|-------|----------|-----|
| Japan | 11/08/02 | YES |
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ASSIGNMENT INFORMATION

Assignee Name:: National Institute of Adv. Industrial Sci. & Tech.
 Street of Mailing Address:: 3-1, Kasumigaseki 1-chome, Chiyoda-ku
 City of Mailing Address:: Tokyo
 Country of Mailing Address:: Japan
 Postal or Zip Code of Mailing Address:: 100-8921